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US Dept. of Commerce ATTY DOCKET NO. Form PTO-1449 (REV. 1/06) PATENT & TRADEMARK OFFICE 127579 Stage of PCT/FR2004/002571 INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) **APPLICANTS** Raphael SALOT et al. FILING DATE April 3, 2006 U.S. PATENT DOCUMENTS Cite Examiner Initials No. Document Number Date Name /S.C./ MÖHWALD et al. 6,475,663 B1 11/05/2002 1. /S.C./ 01/28/1997 BATES et al. 2. 5,597,660 /S.C./ JOHNSON et al. 3. 2002/0187399 A1 12/12/2002 /S.C./ KASAMATSU et al. 6,605,386 B1 08/12/2003 4. /S.C./ IWAMOTO et al. 5. 6,645,667 B1 11/11/2003 /S.C./ 6. 5,567,210 10/22/1996 BATES et al. /S.C./ 7. 04/30/1996 BATES et al. 5,512,147 /S.C./ 8. 10/03/1995 BATES et al. 5,455,126 /S.C./ 9. 6,218,049 B1 04/17/2001 BATES et al. /S.C./ 08/16/1994 BATES et al. 10. 5,338,625 FOREIGN PATENT DOCUMENTS With With Examiner Cite Document Number Country English English Initials Date No. Translation Abstract /S.C./ **EUROPEAN PATENT OFFICE** 11. EP 1 052 712 A1 11/15/2000 /S.C./ 12. EP 1 130 670 A1 09/05/2001 **EUROPEAN PATENT OFFICE** OTHER DOCUMENTS Examiner Cite (Including Author, Title, Date, Pertinent Pages, etc.) Initials No. 13. K.-H. JOO et al.; "Thin Film Lithium Ion Conducting LiBSO Solid Electrolyte"; Solid State Ionics; Vol. 160; 2003; pp. 51-59. /S.C./ Ki Woong KIM et al.; "Microfabrication of LiCoO2 Film Using Liquid Source Misted Chemical Deposition Technique"; 14. /S.C./ Solid State Ionics; Vol. 159; 2003; pp. 25-34. 15. J. B. BATES et al.; "Preferred Orientation of Polycrystalline LiCoO2 Films"; Journal of the Electrochemical Society; Vol. 147, /S.C./ No. 1; 2000; pp. 59-70. **EXAMINER** /Sean Cullen/ Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: April 3, 2006